

Docket No.: K-0319



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
In Haeng Cho

Confirmation No.: 1269

Serial No.: 09/944,378

Group Art Unit: 1746

Filed: September 4, 2001

Examiner: Joseph L. Perrin

Customer No.: 34610

For: WASHING MACHINE AND SYSTEM DATA CHANGING MEHOD OF THE SAME

COMMENTS IN REPLY TO EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE

U.S. Patent and Trademark Office
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Sir:

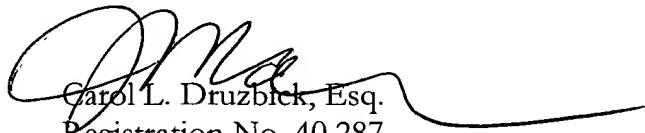
In response to the Notice of Allowability dated August 25, 2005, Applicant respectfully submits the following Comments on Statement of Reasons for Allowance.

The Examiner provided various reasons for allowance of the above-identified application in the Notice of Allowability. Applicants respectfully note that the Examiner has misquoted the language recited in the independent claims.

Accordingly, Applicants respectfully submit that the scope of the allowed claims should not be limited by the comments for reasons of allowance in the Notice of Allowability.

Should there be any questions concerning this communication, please telephone
the undersigned at the telephone number set forth below.

Respectfully submitted,
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